

CPC COOPERATIVE PATENT CLASSIFICATION

G PHYSICS (NOTES omitted)

INSTRUMENTS

G01 MEASURING (counting [G06M](#)); TESTING (NOTES omitted)

G01B MEASURING LENGTH, THICKNESS OR SIMILAR LINEAR DIMENSIONS; MEASURING ANGLES; MEASURING AREAS; MEASURING IRREGULARITIES OF SURFACES OR CONTOURS {(measuring human body, [see the relevant places](#), where such exist, e.g. [A41H 1/00](#), [A43D 1/02](#), [A61B 5/103](#); measuring appliances combined with walking-sticks [A45B 3/08](#); sorting according to dimensions [B07](#); tool-setting or drawing instruments not specially modified for measuring [B23B 49/00](#), [B23Q 15/00](#) - [B23Q 17/00](#), [B43L](#); combinations of measuring devices with writing-appliances [B43K 29/08](#); geodetical, nautical or aeronautical measuring, surveying, rangefinding [G01C](#); photogrammetry [G01C 11/00](#); measuring force or stress, in general [G01L 1/00](#); investigating or analysing particle size, investigating or analysing surface area of porous material [G01N](#); measuring position, distance or direction, in general, by reception or emission of radiowaves or other waves and based on propagation effects, e.g. Doppler effect, propagation time, direction of propagation [G01S](#); geophysical measuring [G01V](#); measuring length or roll diameter of film in cameras or projectors [G03B 1/60](#); combinations of measuring devices with means for controlling or regulating [G05](#); methods or arrangements for converting the position of a manually-operated writing or tracing member into an electrical signal [G06K 11/00](#); measuring elapsed travel of recording medium in recording and playback equipment, sensing diameter of record in autochange gramophones [G11B](#); means structurally associated with electric rotary current collectors for indicating brush wear [H01R 39/58](#); indicating consumption of electrodes in arc lamps [H05B 31/34](#))}

NOTES

1. This subclass covers measuring of position or displacement in terms of linear or angular dimensions.
2. In this subclass, the groups are distinguished by the means of measurement which is of major importance. Thus the mere application of other means for giving a final indication does not affect the classification.
3. Attention is drawn to the Notes following the title of class [G01](#).
4. Machines operated on similar principles to the hand-held devices specified in this subclass are classified with these devices.
5. Measuring arrangements or details thereof covered by two or more of groups [G01B 3/00](#) - [G01B 17/00](#) are classified in group [G01B 21/00](#) if no single other group can be selected as being predominantly applicable.

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| 1/00 | Measuring instruments characterised by the selection of material therefor | 3/04 | . . . rigid |
| | | 3/06 | folding |
| 3/00 | Instruments as specified in the subgroups and characterised by the use of mechanical measuring means (arrangements for measuring particular parameters G01B 5/00 ; devices of general interest specially adapted or mounted for storing and repeatedly paying-out and re-storing lengths of material B65H 75/34) | 3/08 | extensible |
| | | 3/10 | . . . flexible {, e.g. tape measures} |
| NOTE | | | |
| {Group G01B 3/1002 takes precedence over groups G01B 3/1005 - G01B 3/1084 } | | | |
| 3/002 | . {Details} | 3/1002 | {Tape measures without casings} |
| 3/004 | . . {Scales; Graduations} | 3/1005 | {Braking or locking members, i.e. means for preventing rotation or the tape or for holding the tape at a certain position; Damping means, i.e. means for absorbing shock due to rewinding of the tape; Winding mechanisms, e.g. springs, electrical motors, crank-handles} |
| 3/006 | . . . {having both coarse and fine graduation} | | |
| 3/008 | . . {Arrangements for controlling the measuring force} | | |
| 3/02 | . Rulers or tapes with scales or marks for direct reading | 2003/1007 | {Locking members} |

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|-----------|-----------|---|-------------|---------|--|
| 2003/101 | | { acting on the drum } | 3/26 | . . | Plug gauges |
| 2003/1012 | | { engaging the tape in a direction parallel to the tape itself } | 3/28 | . . | Depth gauges |
| 2003/1015 | | { engaging the tape in a direction transversal to the tape itself } | 3/30 | . . | Bars, blocks, or strips in which the distance between a pair of faces is fixed, although it may be preadjustable, e.g. end measure, feeler strip |
| 2003/1017 | | { acting on the whole coil } | 3/303 | . . | { pre-adjustable, e.g. by means of micrometerscrew } |
| 2003/102 | | { Damping means } | 3/306 | . . . | { with inclined slide plane } |
| 2003/1023 | | { Winding mechanisms } | 3/32 | . . | Holders therefor |
| 2003/1025 | | { Hand operated, e.g. crank-handles } | 3/34 | . . | Ring or other apertured gauges, e.g. "go/no-go" gauge |
| 2003/1028 | | { Electrical motors } | 3/36 | . . | for external screw-threads |
| 2003/103 | | { Springs } | 3/38 | . . | Gauges with an open yoke and opposed faces, i.e. calipers, in which the internal distance between the faces is fixed, although it may be preadjustable |
| 2003/1033 | | { Means for activating locking, braking or releasing of the tape, e.g. buttons } | 3/40 | . . | for external screw-threads |
| 2003/1035 | | { by pivotal operation } | 3/42 | . . | of limit-gauge type, i.e. "go/no-go" (G01B 3/40 takes precedence) |
| 2003/1038 | | { by translatory motion operation } | 3/44 | . . . | preadjustable for wear or tolerance |
| 3/1041 | . . . | { Casings, i.e. structures to contain the tape } | 3/46 | . . | Plug gauges for internal dimensions with engaging surfaces which are at a fixed distance, although they may be preadjustable |
| 2003/1043 | | { internal structure and constructional details } | 3/48 | . . | for internal screw-threads |
| 2003/1046 | | { external shape; elements for generating an offset } | 3/50 | . . | of limit-gauge type, i.e. "go/no-go" (G01B 3/48 takes precedence) |
| 2003/1048 | | { mounting elements integral to the casing for fixing to external structures or for holding, e.g. handles } | 3/52 | . . . | preadjustable for wear or tolerance |
| 2003/1051 | | { plurality of tapes within the same casing } | 3/56 | . . | Gauges for measuring angles or tapers, e.g. conical calipers |
| 2003/1053 | | { tape exit slot, e.g. shape or exit direction } | 3/563 | . . | { Protractors (for use in geodesy G01C 1/00; protractor heads for drawing machines B43L 13/08) } |
| 3/1056 | . . . | { End-hooks; Attachment of end-hooks to the tape; Distal and proximal ends of the tape } | 3/566 | . . | { Squares } |
| 2003/1058 | . . . | { Manufacturing or assembling methods } | 5/00 | | Measuring arrangements characterised by the use of mechanical means (instruments of the types covered by group G01B 3/00 per se G01B 3/00) |
| 3/1061 | . . . | { Means for reading or displaying length measurement } | 5/0002 | . . | { Arrangements for supporting, fixing or guiding the measuring instrument or the object to be measured } |
| 2003/1064 | | { Windows, e.g. lens, glass or cross-hairs } | 5/0004 | . . | { Supports (in general F16M; G01B 5/025 takes precedence) } |
| 2003/1066 | | { Index sliding on tape } | 5/0007 | . . | { Surface plates } |
| 2003/1069 | | { Electronic or mechanical displaying means } | 5/0009 | . . | { Guiding surfaces; Arrangements compensating for non-linearity there-of } |
| 3/1071 | . . . | { External support or attachment means, i.e. not provided in the tape measure itself } | 5/0011 | . . | { Arrangements for eliminating or compensation of measuring errors due to temperature or weight } |
| 2003/1074 | | { for the casing } | 5/0014 | . . | { due to temperature (on machine tools B23Q 11/0003) } |
| 2003/1076 | | { for the end-hook } | 5/0016 | . . | { due to weight (on machine tools B23Q 11/001) } |
| 2003/1079 | | { for the tape itself } | 5/0018 | . . | { for measuring key-ways } |
| 3/1082 | . . . | { Details of the tape per se , e.g. scale structure, indicia on scale, particular material for the tape } | 5/0021 | . . | { for measuring the volumetric dimension of an object } |
| 3/1084 | . . . | { Particular applications of tape measures or special adaptations thereto } | 5/0023 | . . | { Measuring of sport goods, e.g. bowling accessories, golfclubs, game balls } |
| 2003/1087 | | { for illuminating } | 5/0025 | . . | { Measuring of vehicle parts (G01B 5/003 takes precedence) } |
| 2003/1089 | | { for drawing, marking, cutting } | 5/0028 | . . | { Brakes, brakeshoes, clutches } |
| 2003/1092 | | { measuring instruments cooperating with the tape measure, e.g. bubble-type level } | 5/003 | . . | { Measuring of motor parts } |
| 2003/1094 | | { for calculating, recording, indicating; aide memoire } | 5/0032 | . . | { Valves, actuating devices for valves } |
| 2003/1097 | | { Tape measures with an adhesive surface } | 5/0035 | . . | { Measuring of dimensions of trees } |
| 3/11 | . . | Chains for measuring length | 5/0037 | . . | { Measuring of dimensions of welds } |
| 3/12 | . . | Measuring wheels | 5/004 | . . | for measuring coordinates of points |
| 3/14 | . . | Templates for checking contours { (templates for mounting doors or windows E04F 21/0007) } | 5/008 | . . | using coordinate measuring machines |
| 3/16 | . . | Compasses, i.e. with a pair of pivoted arms | 5/012 | . . . | Contact-making feeler heads therefor |
| 3/163 | . . | { without measuring scale } | 5/016 | | Constructional details of contacts |
| 3/166 | . . | { provided with a measuring scale } | | | |
| 3/18 | . . | Micrometers | | | |
| 3/20 | . . | Slide gauges | | | |
| 3/205 | . . | { provided with a counter for digital indication of the measured dimension } | | | |
| 3/22 | . . | Feeler-pin gauges, e.g. dial gauges (for determining profiles G01B 5/20) | | | |
| 3/24 | . . | with open yoke, i.e. calipers | | | |

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| 5/02 | . for measuring length, width or thickness (G01B 5/004 , G01B 5/08 take precedence) | 7/001 | . {Constructional details of gauge heads (G01B 7/012 takes precedence)} |
| 5/025 | . . {Measuring of circumference; Measuring length of ring-shaped articles (G01B 5/0035 takes precedence)} | 7/002 | . {Constructional details of contacts for gauges actuating one or more contacts (G01B 7/016 takes precedence)} |
| 5/04 | . . specially adapted for measuring length or width of objects while moving | 7/003 | . {for measuring position, not involving coordinate determination (coordinate measuring G01B 7/004)} |
| 5/043 | . . . {for measuring length} | 7/004 | . for measuring coordinates of points |
| 5/046 | . . . {for measuring width} | 7/008 | . . using coordinate measuring machines |
| 5/06 | . . for measuring thickness | 7/012 | . . . Contact-making feeler heads therefor |
| 5/061 | . . . {height gauges} | 7/016 | Constructional details of contacts |
| 5/063 | {provided with a slide which may be moved along a vertical support by means of a micrometer screw} | 7/02 | . for measuring length, width or thickness (G01B 7/004 , G01B 7/12 take precedence) |
| 5/065 | {provided with a slide which may be fixed along its vertical support in discrete calibrated position} | 7/023 | . . {for measuring distance between sensor and object (G01B 7/082 and G01B 7/102 take precedence)} |
| 5/066 | . . . {of coating} | 7/026 | . . {for measuring length of cable, band or the like, which has been paid out, e.g. from a reel (measuring length of objects while moving G01B 7/04)} |
| 5/068 | . . . {of objects while moving (G01B 5/066 takes precedence)} | 7/04 | . . specially adapted for measuring length or width of objects while moving |
| 5/08 | . for measuring diameters {(G01B 5/0035 takes precedence; measuring radius of curvature G01B 5/213)} | 7/042 | . . . {for measuring length} |
| 5/10 | . . of objects while moving | 7/044 | {using capacitive means} |
| 5/12 | . . internal diameters | 7/046 | {using magnetic means} |
| 5/14 | . for measuring distance or clearance between spaced objects or spaced apertures (G01B 5/24 takes precedence) | 7/048 | . . . {for measuring width} |
| 5/143 | . . {between holes on a workpiece} | 7/06 | . . for measuring thickness {(measuring during the manufacture of coatings C23C 14/54)} |
| 5/146 | . . {measuring play on bearings} | 7/063 | . . . {using piezo-electric resonators} |
| 5/16 | . . between a succession of regularly spaced objects or regularly spaced apertures | 7/066 | {for measuring thickness of coating (apparatus or processes for the manufacture of piezo-electric or electrostrictive resonators for obtaining desired frequency H03H 3/04)} |
| 5/163 | . . . {of screw-threads} | 7/08 | . . . {using capacitive means} |
| 5/166 | . . . {of gear teeth} | 7/082 | {Height gauges} |
| 5/18 | . for measuring depth | 7/085 | {for measuring thickness of coating} |
| 5/20 | . for measuring contours or curvatures | 7/087 | {for measuring of objects while moving (G01B 7/085 takes precedence)} |
| 5/201 | . . {for measuring roundness} | 7/10 | . . . {using magnetic means, e.g. by measuring change of reluctance} |
| 5/202 | . . {of gears} | 7/102 | {Height gauges} |
| 5/204 | . . {of screw-threads} | 7/105 | {for measuring thickness of coating} |
| 5/205 | . . {of turbine blades or propellers} | 7/107 | {for measuring objects while moving (G01B 7/105 takes precedence)} |
| 5/207 | . . using a plurality of fixed, simultaneously operating transducers (G01B 5/213 - G01B 5/22 take precedence) | 7/12 | . for measuring diameters |
| 5/213 | . . for measuring radius of curvature | 7/125 | . . {of objects while moving} |
| 5/22 | . . Spherometers | 7/13 | . . Internal diameters |
| 5/24 | . for measuring angles or tapers; for testing alignment of axes | 7/14 | . for measuring distance or clearance between spaced objects or spaced apertures (G01B 7/30 takes precedence) |
| 5/241 | . . {for measuring conicity} | 7/142 | . . {between holes on a workpiece} |
| 5/242 | . . {Sine bars; Sine plates} | 7/144 | . . {Measuring play on bearings} |
| 5/243 | . . {for measuring chamfer (see G01B 3/56)} | 7/146 | . . {Measuring on gear teeth} |
| 5/245 | . . for testing perpendicularity | 7/148 | . . {Measuring on screw threads} |
| 5/25 | . . for testing the alignment of axes | 7/15 | . . being regularly spaced |
| 5/252 | . . . for measuring eccentricity, i.e. lateral shift between two parallel axes | 7/16 | . for measuring deformation in a solid, e.g. by resistance strain gauge |
| 5/255 | . . for testing wheel alignment | 7/18 | . . {using change in resistance} |
| 5/26 | . for measuring areas, e.g. planimeter (integrators in general G06G) | 7/20 | . . . {formed by printed-circuit technique} |
| 5/28 | . for measuring roughness or irregularity of surfaces | 7/22 | . . {using change in capacitance} |
| 5/285 | . . {for controlling evenness} | 7/24 | . . using change in magnetic properties |
| 5/30 | . for measuring the deformation in a solid, e.g. mechanical strain gauge | 7/26 | . for measuring depth |
| 7/00 | Measuring arrangements characterised by the use of electric or magnetic means | 7/28 | . for measuring contours or curvatures |

- 7/281 . . {for measuring contour or curvature along an axis, e.g. axial curvature of a pipeline or along a series of feeder rollers}
- 7/282 . . {for measuring roundness}
- 7/283 . . {of gears}
- 7/284 . . {of screw-threads}
- 7/285 . . {of propellers or turbine blades}
- 7/286 . . {Spherometers}
- 7/287 . . using a plurality of fixed, simultaneously operating transducers ([G01B 7/293](#) takes precedence)
- 7/293 . . for measuring radius of curvature
- 7/30 . for measuring angles or tapers; for testing the alignment of axes
- 7/305 . . for testing perpendicularity
- 7/31 . . for testing the alignment of axes
- 7/312 . . . for measuring eccentricity, i.e. lateral shift between two parallel axes
- 7/315 . . for testing wheel alignment
- 7/32 . for measuring areas ([integrators in general G06G](#))
- 7/34 . for measuring roughness or irregularity of surfaces
- 7/345 . . {for measuring evenness}
- 9/00 Instruments as specified in the subgroups and characterised by the use of optical measuring means (arrangements for measuring particular parameters [G01B 11/00](#))**
- 9/02 . Interferometers {for determining dimensional properties of, or relations between, measurement objects}
- 9/02001 . . {characterised by manipulating or generating specific radiation properties}
- 9/02002 . . . {Frequency variation}
- 9/02003 {by using beat frequencies generated by mixing of two or more frequencies}
- 9/02004 {by using a continuous frequency sweep or scan}
- 9/02005 {by using discrete frequency stepping or switching}
- 9/02007 . . . {Two or more frequencies or sources used for interferometric measurement ([using only beat \[G01B 9/02003\]\(#\)](#))}
- 9/02008 {by using a frequency comb}
- 9/02009 {by using two or more low coherence lengths using different or varying spectral width}
- 9/0201 . . . {using temporal phase variation}
- 9/02011 . . . {using temporal polarization variation}
- 9/02012 . . . {using temporal intensity variation}
- 9/02014 {by using pulsed light}
- 9/02015 . . {characterised by a particular beam path configuration}
- 9/02016 . . . {contacting two or more objects}
- 9/02017 . . . {contacting one object several times}
- 9/02018 {Multiple-pass interferometer, e.g. double pass}
- 9/02019 {contacting different points on same face of object}
- 9/02021 {contacting different faces of object, e.g. opposite faces}
- 9/02022 . . . {contacting one object by grazing incidence}
- 9/02023 . . . {Indirect probing of object, e.g. via influence on cavity or fibre}
- 9/02024 . . . {Measuring in transmission, i.e. light traverses the object}
- 9/02025 {Interference between three or more discrete surfaces}
- 9/02027 {Two or more interferometric channels or interferometers}
- 9/02028 {Two or more reference or object arms in one interferometer}
- 9/02029 {Combination with non-interferometric systems, i.e. for measuring the object}
- 9/0203 {With imaging systems}
- 9/02031 {With non-optical systems, e.g. tactile}
- 9/02032 {generating a spatial carrier frequency, e.g. by creating lateral or angular offset between reference and object beam ([shearing interferometers \[G01B 9/02098\]\(#\)](#))}
- 9/02034 . . {characterised by particularly shaped beams or wavefronts}
- 9/02035 . . . {Shaping the focal point, e.g. elongated focus}
- 9/02036 {by using chromatic effects, e.g. a wavelength dependent focal point}
- 9/02037 {by generating a transverse line focus}
- 9/02038 . . . {Shaping the wavefront, e.g. generating a spherical wavefront}
- 9/02039 {by matching the wavefront with a particular object surface shape}
- 9/02041 . . {characterised by particular imaging or detection techniques}
- 9/02042 . . . {Confocal imaging}
- 9/02043 . . . {Imaging of the Fourier or pupil or back focal plane, i.e. angle resolved imaging}
- 9/02044 . . . {Imaging in the frequency domain, e.g. by using a spectrometer}
- 9/02045 . . . {using the Doppler effect}
- 9/02047 . . . {using digital holographic imaging, e.g. lensless phase imaging without hologram in the reference path}
- 9/02048 . . . {Rough and fine measurement}
- 9/02049 . . {characterised by particular mechanical design details}
- 9/0205 . . . {of probe head}
- 9/02051 . . . {Integrated design, e.g. on-chip or monolithic}
- 9/02052 . . . {Protecting, e.g. shock absorbing, arrangements}
- 9/02054 . . . {Hand held}
- 9/02055 . . {characterised by error reduction techniques}
- 9/02056 . . . {Passive error reduction, i.e. not varying during measurement, e.g. by constructional details of optics}
- 9/02057 {by using common path configuration, i.e. reference and object path almost entirely overlapping}
- 9/02058 {by particular optical compensation or alignment elements, e.g. dispersion compensation}
- 9/02059 {Reducing effect of parasitic reflections, e.g. cyclic errors}
- 9/02061 {Reducing or preventing effect of tilt or misalignment, e.g. of object or reference mirror}
- 9/02062 . . . {Active error reduction, i.e. varying with time}
- 9/02063 {by particular alignment of focus position, e.g. dynamic focussing in optical coherence tomography}

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| 9/02064 | {by particular adjustment of coherence gate, i.e. adjusting position of zero path difference in low coherence interferometry} | 9/08 | . Optical projection comparators |
| 9/02065 | {using a second interferometer before or after measuring interferometer} | 9/10 | . Goniometers for measuring angles between surfaces |
| 9/02067 | {by electronic control systems, i.e. using feedback acting on optics or light} | 11/00 | Measuring arrangements characterised by the use of optical means (instruments of the types covered by group G01B 9/00 per se G01B 9/00) |
| 9/02068 | {Auto-alignment of optical elements} | 11/002 | . {for measuring two or more coordinates} |
| 9/02069 | {Synchronization of light source or manipulator and detector} | 11/005 | . . {coordinate measuring machines} |
| 9/0207 | . . . {Error reduction by correction of the measurement signal based on independently determined error sources, e.g. using a reference interferometer} | 11/007 | . . . {feeler heads therefor} |
| 9/02071 | {by measuring path difference independently from interferometer} | 11/02 | . for measuring length, width or thickness (G01B 11/08 takes precedence) |
| 9/02072 | {by calibration or testing of interferometer} | 11/022 | . . {by means of tv-camera scanning} |
| 9/02074 | {of the detector} | 11/024 | . . {by means of diode-array scanning} |
| 9/02075 | . . . {of particular errors} | 11/026 | . . {by measuring distance between sensor and object (G01B 11/0608 takes precedence)} |
| 9/02076 | {Caused by motion} | 11/028 | . . {by measuring lateral position of a boundary of the object (G01B 11/022, G01B 11/024, G01B 11/04 take precedence)} |
| 9/02077 | {of the object} | 11/03 | . . by measuring coordinates of points |
| 9/02078 | {Caused by ambiguity} | 11/04 | . . specially adapted for measuring length or width of objects while moving |
| 9/02079 | {Quadrature detection, i.e. detecting relatively phase-shifted signals} | 11/043 | . . . {for measuring length} |
| 9/02081 | {simultaneous quadrature detection, e.g. by spatial phase shifting} | 11/046 | . . . {for measuring width} |
| 9/02082 | {Caused by speckles} | 11/06 | . . for measuring thickness, e.g. of sheet material (thickness measurement by thermal means G01B 21/085) |
| 9/02083 | . . {characterised by particular signal processing and presentation} | 11/0608 | . . . {Height gauges} |
| 9/02084 | . . . {Processing in the Fourier or frequency domain when not imaged in the frequency domain} | 11/0616 | . . . {of coating} |
| 9/02085 | . . . {Combining two or more images of different regions} | 11/0625 | {with measurement of absorption or reflection} |
| 9/02087 | . . . {Combining two or more images of the same region} | 11/0633 | {using one or more discrete wavelengths} |
| 9/02088 | . . . {Matching signals with a database} | 11/0641 | {with measurement of polarization} |
| 9/02089 | . . . {Displaying the signal, e.g. for user interaction} | 11/065 | {using one or more discrete wavelengths} |
| 9/0209 | . . {Non-tomographic low coherence interferometers, e.g. low coherence interferometry, scanning white light interferometry, optical frequency domain interferometry or reflectometry} | 11/0658 | {with measurement of emissivity or reradiation} |
| 9/02091 | . . {Tomographic low coherence interferometers, e.g. optical coherence tomography} | 11/0666 | {using an exciting beam and a detection beam including surface acoustic waves [SAW]} |
| 9/02092 | . . {Self-mixing interferometers, i.e. feedback of light from object into laser cavity} | 11/0675 | {using interferometry} |
| 9/02094 | . . {Speckle interferometers, i.e. for detecting changes in speckle pattern} | 11/0683 | {measurement during deposition or removal of the layer} |
| 9/02095 | . . . {detecting deformation from original shape} | 11/0691 | {of objects while moving (G01B 11/0616 takes precedence)} |
| 9/02096 | . . . {detecting a contour or curvature} | 11/08 | . for measuring diameters |
| 9/02097 | . . {Self-interferometers, i.e. the object beam interfering with a shifted version of itself} | 11/10 | . . of objects while moving |
| 9/02098 | . . . {shearing interferometers} | 11/105 | . . . {using photoelectric detection means} |
| 9/021 | . . using holographic techniques | 11/12 | . . internal diameters |
| 9/023 | . . . for contour producing (G01B 9/025 - G01B 9/029 take precedence) | 11/14 | . for measuring distance or clearance between spaced objects or spaced apertures (G01B 11/26 takes precedence; rangefinders G01C) |
| 9/025 | . . . Double exposure technique | 11/16 | . for measuring the deformation in a solid, e.g. optical strain gauge |
| 9/027 | . . . in real time | 11/161 | . . {by interferometric means} |
| 9/029 | . . . by time averaging | 11/162 | . . . {by speckle- or shearing interferometry} |
| 9/04 | . Measuring microscopes (microscopes in general G02B 21/00) | 11/164 | . . . {by holographic interferometry} |
| 9/06 | . Measuring telescopes (telescopes in general G02B 23/00) | 11/165 | . . {by means of a grating deformed by the object} |
| | | 11/167 | . . {by projecting a pattern on the object} |
| | | 11/168 | . . {by means of polarisation} |
| | | 11/18 | . . {using photoelastic elements} |
| | | 11/20 | . . {using brittle lacquer} |
| | | 11/22 | . for measuring depth |
| | | 11/24 | . for measuring contours or curvatures |
| | | 11/2408 | . . {for measuring roundness} |

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| 11/2416 | . . {of gears (optical projection profile comparators G01B 9/08)} | 13/18 | . for measuring angles or tapers; for testing the alignment of axes |
| 11/2425 | . . {of screw-threads} | 13/19 | . . for testing the alignment of axes |
| 11/2433 | . . {for measuring outlines by shadow casting} | 13/195 | . . for testing wheel alignment |
| 11/2441 | . . {using interferometry} | 13/20 | . for measuring areas, e.g. pneumatic planimeter (integrators in general G06G) |
| 11/245 | . . using a plurality of fixed, simultaneously operating transducers (G01B 11/2408 - G01B 11/2425 , } G01B 11/255 take precedence) | 13/22 | . for measuring roughness or irregularity of surfaces |
| 11/25 | . . by projecting a pattern, e.g. {one or more lines,} moiré fringes on the object (G01B 11/255 takes precedence; image analysis for depth or shape recovery G06T 7/50) | 13/24 | . for measuring the deformation in a solid |
| 11/2504 | . . . {Calibration devices} | 15/00 | Measuring arrangements characterised by the use of wave or particle radiation (G01B 9/00, G01B 11/00 take precedence {; by radar technique G01S}) |
| 11/2509 | . . . {Color coding} | 15/02 | . for measuring thickness |
| 11/2513 | . . . {with several lines being projected in more than one direction, e.g. grids, patterns} | 15/025 | . . {by measuring absorption} |
| 11/2518 | . . . {Projection by scanning of the object} | 15/04 | . for measuring contours or curvatures |
| 11/2522 | {the position of the object changing and being recorded} | 15/045 | . . {by measuring absorption} |
| 11/2527 | {with phase change by in-plane movement of the pattern} | 15/06 | . for measuring the deformation in a solid |
| 11/2531 | . . . {using several gratings, projected with variable angle of incidence on the object, and one detection device} | 15/08 | . for measuring roughness or irregularity of surfaces |
| 11/2536 | . . . {using several gratings with variable grating pitch, projected on the object with the same angle of incidence} | 17/00 | Measuring arrangements characterised by the use of subsonic, sonic or ultrasonic vibrations {(by sonar technique G01S 15/00)} |
| 11/254 | . . . {Projection of a pattern, viewing through a pattern, e.g. moiré} | 17/02 | . for measuring thickness |
| 11/2545 | . . . {with one projection direction and several detection directions, e.g. stereo} | 17/025 | . . {for measuring thickness of coating} |
| 11/255 | . . for measuring radius of curvature {(measuring diameter G01B 11/08)} | 17/04 | . for measuring the deformation in a solid, e.g. by vibrating string |
| 11/26 | . for measuring angles or tapers; for testing the alignment of axes | 17/06 | . for measuring contours or curvatures |
| 11/27 | . . for testing the alignment of axes {(means for centering or aligning a light guide within a ferrule G02B 6/3834)} | 17/08 | . for measuring roughness or irregularity of surfaces |
| 11/272 | . . . {using photoelectric detection means} | 21/00 | Measuring arrangements or details thereof in so far as they are not adapted to particular types of measuring means of the preceding groups |
| 11/275 | . . for testing wheel alignment | NOTE | Measuring arrangements or details thereof covered by two or more of groups G01B 3/00 - G01B 17/00 are classified in this group if no single other group can be selected as being predominantly applicable. |
| 11/2755 | . . . {using photoelectric detection means} | 21/02 | . for measuring length, width, or thickness (G01B 21/10 takes precedence) |
| 11/28 | . for measuring areas (integrators in general G06G) | 21/04 | . . by measuring coordinates of points |
| 11/285 | . . {using photoelectric detection means} | 21/042 | . . . {Calibration or calibration artifacts (G01B 3/30 , G01B 9/02072 take precedence)} |
| 11/30 | . for measuring roughness or irregularity of surfaces | 21/045 | . . . {Correction of measurements (G01B 9/02055 takes precedence)} |
| 11/303 | . . {using photoelectric detection means} | 21/047 | . . . {Accessories, e.g. for positioning, for tool-setting, for measuring probes} |
| 11/306 | . . {for measuring evenness} | 21/06 | . . specially adapted for measuring length or width of objects while moving {(unwinding or rewinding apparatus incorporating length measuring devices B65H 16/025)} |
| 13/00 | Measuring arrangements characterised by the use of fluids {(pressure regulation G05D 16/00)} | 21/065 | . . . {for stretchable materials} |
| 13/02 | . for measuring length, width or thickness (G01B 13/08 takes precedence) | 21/08 | . . for measuring thickness |
| 13/03 | . . by measuring coordinates of points | 21/085 | . . . {using thermal means} |
| 13/04 | . . specially adapted for measuring length or width of objects while moving | 21/10 | . for measuring diameters |
| 13/06 | . . for measuring thickness, e.g. of sheet material | 21/12 | . . of objects while moving |
| 13/065 | . . . {Height gauges} | 21/14 | . . internal diameters {(of boreholes or wells E21B 47/08)} |
| 13/08 | . for measuring diameters | 21/16 | . for measuring distance or clearance between spaced objects |
| 13/10 | . . internal diameters | 21/18 | . for measuring depth |
| 13/12 | . for measuring distance or clearance between spaced objects or spaced apertures (G01B 13/18 takes precedence) | | |
| 13/14 | . for measuring depth | | |
| 13/16 | . for measuring contours or curvatures | | |

G01B

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| 21/20 | . for measuring contours or curvatures, e.g. determining profile | 2210/58 | . Wireless transmission of information between a sensor or probe and a control or evaluation unit |
| 21/22 | . for measuring angles or tapers; for testing the alignment of axes | 2210/60 | . Unique sensor identification |
| 21/24 | . . for testing alignment of axes | 2210/62 | . Support for workpiece air film or bearing with positive or negative pressure |
| 21/26 | . . for testing wheel alignment | 2210/64 | . Interconnection or interfacing through or under capping or via rear of substrate in microsensors |
| 21/28 | . for measuring areas (integrators in general G06G) | 2210/66 | . Rock or ground anchors having deformation measuring means |
| 21/30 | . for measuring roughness or irregularity of surfaces | | |
| 21/32 | . for measuring the deformation in a solid | | |
| 2210/00 | Aspects not specifically covered by any group under G01B, e.g. of wheel alignment, caliper-like sensors | 2290/00 | Aspects of interferometers not specifically covered by any group under G01B 9/02 |
| 2210/10 | . Wheel alignment | 2290/10 | . Astronomic interferometers |
| 2210/12 | . . Method or fixture for calibrating the wheel aligner | 2290/15 | . Cat eye, i.e. reflection always parallel to incoming beam |
| 2210/14 | . . One or more cameras or other optical devices capable of acquiring a two-dimensional image | 2290/20 | . Dispersive element for generating dispersion |
| 2210/143 | . . . One or more cameras on each side of a vehicle in the main embodiment | 2290/25 | . Fabry-Perot in interferometer, e.g. etalon, cavity |
| 2210/146 | . . . Two or more cameras imaging the same area | 2290/30 | . Grating as beam-splitter |
| 2210/16 | . . Active or passive device attached to the chassis of a vehicle | 2290/35 | . Mechanical variable delay line |
| 2210/18 | . . Specially developed for using with motorbikes or other two-wheeled vehicles | 2290/40 | . Non-mechanical variable delay line |
| 2210/20 | . . Vehicle in a state of translatory motion | 2290/45 | . Multiple detectors for detecting interferometer signals |
| 2210/22 | . . Wheels in a state of motion supported on rollers, rotating platform or other structure substantially capable of only one degree of rotational freedom | 2290/50 | . Pupil plane manipulation, e.g. filtering light of certain reflection angles |
| 2210/24 | . . Specially developed for using with trucks or other heavy-duty vehicles | 2290/55 | . Quantum effects |
| 2210/26 | . . Algorithms, instructions, databases, computerized methods and graphical user interfaces employed by a user in conjunction with the wheel aligner | 2290/60 | . Reference interferometer, i.e. additional interferometer not interacting with object |
| 2210/28 | . . Beam projector and related sensors, camera, inclinometer or other active sensing or projecting device | 2290/65 | . Spatial scanning object beam |
| 2210/283 | . . . Beam projectors and related sensors | 2290/70 | . Using polarization in the interferometer |
| 2210/286 | . . . Projecting a light pattern on the wheel or vehicle body | | |
| 2210/30 | . . Reference markings, reflector, scale or other passive device | | |
| 2210/303 | . . . fixed to the ground or to the measuring station | | |
| 2210/306 | . . . Mirror, prism or other reflector | | |
| 2210/40 | . Caliper-like sensors | | |
| 2210/42 | . . with one or more detectors on a single side of the object to be measured and with a backing surface of support or reference on the other side | | |
| 2210/44 | . . with detectors on both sides of the object to be measured | | |
| 2210/46 | . . with one or more detectors on a single side of the object to be measured and with a transmitter on the other side | | |
| 2210/48 | . . for measurement of a wafer | | |
| 2210/50 | . Using chromatic effects to achieve wavelength-dependent depth resolution | | |
| 2210/52 | . Combining or merging partially overlapping images to an overall image | | |
| 2210/54 | . Revolving an optical measuring instrument around a body | | |
| 2210/56 | . Measuring geometric parameters of semiconductor structures, e.g. profile, critical dimensions or trench depth | | |